

# In-Situ laser (TDLS) gas analyzer

PROCESS & EMISSIONS MONITORING SYSTEMS



- $\checkmark$  No sampling system needed
- $\checkmark$  No gas temperature influence
- ✓ Gas matrix interference free
- ✓ Calibration free measurement
- High precision gas concentration measurement and fast response time
- New Embedded ClearPath functionality

#### 💡 CLEARPATH

Interference of relative humidity,  $O_2$  or  $CO_2$  is removed in purging areas.

Operator's benefits:

- No need for N<sub>2</sub> or dry air purge
- High accuracy of O<sub>2</sub> measurement
- High accuracy of H<sub>2</sub>O measurement
- High accuracy of CO<sub>2</sub> measurement



Embedded web server

#### **KEY FEATURES**

- Highly sensitive and selective measurement
- High signal-to-noise ratio
- No measurement drift
- Response time 1 s
- Large dynamic range from ppm to %
- Real-time communication between Transmitter (Tx) and Receiver (Rx)
- Robust, ready for Ex Zone II (certification to come)

#### A WIDE RANGE OF APPLICATIONS FOR CEMS AND PROCESS

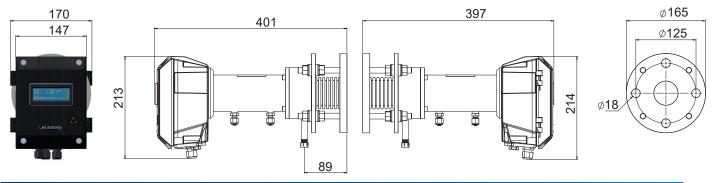
- Ammonia slip control (DeNox)
- Process and combustion control
- HF emission control in aluminum plant
- HCI/SO<sub>2</sub> abatement control
- Ethylene cracking furnace control
- HCl level in semiconductor production
- Ammonia concentration control in pet food, fertilizer plants, etc.

## CUSTOMER BENEFITS

- > Low maintenance and cost of ownership
- > No need for  $N_2$  or dry air purge: Oil & dust free air instrument is enough
- > Process optimization leading to reduction of operating costs

2000XI

# In-Situ laser (TDLS) gas analyzer LAS 5000XD



## **TECHNICAL SPECIFICATIONS**

Concentration ranges:	
$NH_3 + H_2O$	0–10 ppm / 0–5000 ppm + 0–5% / 0–40%
HF	0-3 ppm / 0-500 ppm
$CO + H_2O$	0-50 ppm / 0-1% + 0-5% / 0-40%
$CO + CO_2$	0-1% / 0-100% + 0-1% / 0-100%
$CO_2 + H_2O$ $O_2$	Coming soon Coming soon
$HCI + H_2O$	Coming soon
Other gases	Available upon request
Technology	<ul> <li>ADLAS (Advanced Detection Laser Absorption Spectroscopy)</li> <li>Optimized Opto-Mechanical Design</li> <li>High Speed Low-Drift Electronics</li> <li>Independent Spectroscopy Technique</li> </ul>
Lower Detection Limit	< 1% of FS
Response Time (0-90%) - Short	1 s
Lack of fit/Linearity	$\leq \pm 1\%$
Flue Gas Temperature (°C max)	
$NH_3 + H_2O / HCI + H_2O / HF$	+400 °C (Depends on the concentration range)
$CO + H_2O / O_2 / CO + CO_2$	+1200 °C (Depends on the concentration range)
Flue Gas Pressure	2 bars max (absolute)
Display on Tx	4 x 20 LCD
Communication	Modbus RTU (RS485) / Ethernet (RJ45) - Web server
Power supply type	+ 24 V DC, ripple and noise 50 mV
Power consumption	15 W (warm-up), < 15 W in standard use
Recommended T° (ambient)	-20 °C to +55 °C
IP index Tx & Rx enclosures	IP65
Flange specification requirement on stack	DN50 PN16, 2" - 150 lbs, Class 150
Flange material	SS 316 L
Air consumption (main purge - necessary)	5-50 L/min (to adjust according to site conditions) (dry and oil free, ISO 8573.1 Class 2-3)
Air consumption (secondary purge - recommended)	2-3 L/min (dry and oil free, ISO 8573.1 Class 2-3)
Stack diameter compatibility	From 0.5 to 20 m
Note - The technical specifications are defined in th	e following conditions: Gas temperature = $25 ^{\circ}\text{C}$ / gas

Note - The technical specifications are defined in the following conditions: Gas temperature = 25 °C / gas pressure = 1013 mbar / pathlength = 100 cm / ambient temperature = 25 °C

## OPTIONS

Analog I/O (2 x 4-20 mA/2 x 4-20 mA) - Digital Output (2 relays)

Junction Box : Thermal Shield Audit Cell Inline Cell Alignment Tool Weather protection covers





